

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Hong-Jyh Li	Examiner:	Phillip A. Johnston
Serial No.:	10/816,503	Group Art Unit:	2881
Filed:	April 1, 2004	Docket No.:	Q331.128.101/2004P51130US
Title:	PLASMA ION IMPLANTATION SYSTEM		

AMENDMENT AND RESPONSE

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This Amendment and Response is in reply to the Non-Final Office Action mailed May 28, 2008. Please amend the above-identified patent application as follows: